



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Inventors: Jiping Li; Peter G. Borden;  
Assignee: Applied Materials, Inc.  
Title: Evaluating Sidewall Coverage In A Semiconductor Wafer  
Serial No.: 09/788,273 Filing Date: Feb. 16, 2001  
Examiner: Michelle Estrada Group Art Unit: 2823  
Docket No.: BOX009 US Confirmation No: 6335

Santa Clara, California  
June 20, 2003

COMMISSIONER FOR PATENTS  
Washington, D. C. 20231

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, §1.97 and §1.98, the Applicants submit for consideration in the above-identified patent application the documents listed on the accompanying Form PTO-1449. The Examiner is requested to make these documents of record. Copies of the cited documents are enclosed herewith. Applicants would appreciate the Examiner initialing and returning the Form PTO-1449, indicating that the information has been considered by the Examiner, and made of record herein.

To the extent that U.S patent application(s) are included in the cited documents, and the Examiner initials the related entry in the PTO-1449, Applicants presume that the Examiner has access to and has reviewed the files thereof for any office actions, amendments or other materials that may be relevant to the patentability of the claims in the above-identified application. For any such U.S. patent application(s) that are currently pending, the Applicants further presume that the Examiner will consider any future office actions, amendments or other materials in the file thereof that may be relevant to the patentability of the claims in the above-identified application.. If the Applicants' understanding in this regard is not correct, please notify the undersigned so that copies of any such office actions, amendments or other materials not provided herewith can be submitted to the Examiner.

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Since this IDS is being submitted after an Office Action, Applicants are paying the related fee as indicated in the attached fee transmittal. If any additional fee is required, please charge the Deposit Account 50-2263 while referencing the Docket No. BOX009 US.

The information contained in this Information Disclosure Statement is to the best of my knowledge and is not to be construed as a representation that: (i) a complete search has been made; (ii) additional information material to the examination of this application does not exist; (iii) the information, data, results and the like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

**Via Express Mail Label No.**  
**ER 205 699 956 US**

Respectfully submitted,



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